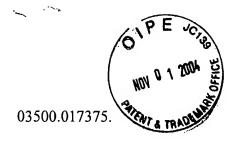
IFW



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Examiner: John S Y Chu	
MASAHIKO KUBOTA, ET AL.	:) Group Art Unit: 1752	
Application No.: 10/615,302	;)	
Filed: July 9, 2003	:)	
E. METHOD OF PRODUCING MIC	, ;	
For: METHOD OF PRODUCING MIC STRUCTURE, METHOD OF	;	
PRODUCING LIQUID DISCHAR	•	
HEAD, AND LIQUID DISCHAR HEAD BY THE SAME	October 29, 2004	
Commissioner for Patents		
P.O. Box 1450		
Alexandria VA 22313-1450		

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated October 1, 2004, Applicants elect, without traverse, to prosecute Group II (Claims 13-16, and 33-36) for initial prosecution. Favorable consideration of the elected claims is respectfully requested.

Applicants' undersigned attorney may be reached in our New York Office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address listed below.

Respectfully submitted,

Peter G. Thurlow

Attorney for Applicants Registration No.: 47,138

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